

INFORMATION DISCLOSURE STATEMENT BY APPLICANT	Application No.	10/772,120	
	Filing Date	February 3, 2004	
	First Named Inventor	Clarence Chui	
	Art Unit	2629	
(Multiple sheets used when necessary)		Examiner	David Lee Lewis
SHEET 1 OF 1		Attorney Docket No.	IRDM.002A/IDC-0023

U.S. PATENT DOCUMENTS					
Examiner Initials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
/DL/	1	5,784,189	7/21/1998	Bozler et al.	
/DL/	2	6,433,917	8/1/2002	Mei et al.	
/DL/	3	6,813,060	11/2/2004	Garcia et al.	
/DL/	4	7,123,216	10/17/2006	Miles	
/DL/	5	7,161,728	1/9/2007	Sampsel et al.	
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/DL/	7	2002-0000959	1/3/2002	Colgan et al.	
/DL/	8	2004-0026757	2/12/2004	Crane et al.	

FOREIGN PATENT DOCUMENTS						
Examiner Initials	Cite No.	Foreign Patent Document Country Code-Number-Kind Code Example: JP 1234567 A1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear	T ¹
/DL/	9	JP 2002 175053	6/21/2002	Sony Corp.		X-abstract

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ¹
/DL/	10	Miles, MEMS-based interferometric modulator for display applications, Part of the SPIE Conference on Micromachined Devices and Components, vol. 3876, pp. 20-28 (1999).	
/DL/	11	Miles et al., 5.3: Digital Paper™: Reflective displays using interferometric modulation, SID Digest, Vol. XXXI, 2000 pp. 32-35	
/DL/	12	IPRP for PCT/US095/002359 filed January 26, 2005	

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Examiner Signature	/David Lewis/	Date Considered	08/20/2008
<p>*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>			

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